

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

JC05 Rec'd PCT/PTO 19 SEP 2005
10/549621

In re application of:

Dirk BREIDT *et al.*

Serial No: TBA

Filed: September 20, 2005

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)
) Group Art No. TBA

)
) Examiner: TBA

)
) Docket No. 000475.00012

For: Body Having A Smooth Diamond Layer,
Device And Method Therefor

INFORMATION DISCLOSURE STATEMENT

Commissioner of Patents
U.S. Patent and Trademark Office
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Randolph Building
401 Dulany Street
Alexandria, VA 22314

Sir:

Pursuant to 37 C.F.R. §1.56 and in compliance with 37 C.F.R. §1.97, Applicants submit herewith one Form PTO-1449 identifying information for consideration by the Examiner.

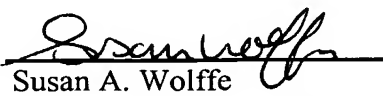
Copies of the cited documents were provided with the International Search Report for the corresponding PCT application.

If the Patent and Trademark Office determines that a fee is required, please charge our Deposit Account No. 19-0733.

Respectfully submitted,

BANNER & WITCOFF, LTD.

Date: 9/20/05

By: 
Susan A. Wolfe
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SAW/sdm

USPTO Form 1449 U.S. Department of Commerce Patent and Trademark Office INFORMATION DISCLOSURE CITATION Sheet 1 of 1		<table border="1" style="width: 100%; border-collapse: collapse;"> <tr> <td style="width: 60%;"> Attorney Docket No. 000475.00012 </td> <td style="width: 40%; text-align: center; vertical-align: middle;"> <div style="font-size: 2em; font-weight: bold;">10/549621</div> <div style="font-size: 0.8em;">Serial No. TBA</div> </td> </tr> <tr> <td colspan="2"> Applicant(s): Dirk BREIDT et al </td> </tr> <tr> <td> Filing Date: September 20, 2005 </td> <td> Group: TBA </td> </tr> </table>		Attorney Docket No. 000475.00012	<div style="font-size: 2em; font-weight: bold;">10/549621</div> <div style="font-size: 0.8em;">Serial No. TBA</div>	Applicant(s): Dirk BREIDT et al		Filing Date: September 20, 2005	Group: TBA
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U.S. PATENT DOCUMENTS									
Examiner Initial	Patent No.	Date	Name	Class	Subclass	Filing Date (if appropriate)			
	US 5 567 522 A	22 October 1996	TAKAHASHI, T et al.						
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Examiner Initial	Document No.	Date	Country	Class	Subclass	Translation			
						YES	NO		
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EXAMINER				DATE CONSIDERED					
<small>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.</small>									